

4~6wafers Fully automatic slot developing machine

Model: SA-SDM-48LS

SA-SDM-48LS is made of durable stainless steel with flexible operation modes. Equipped with robotic arms, it ensures consistent processing quality. It adopts nitrogen aeration and tank lifting to boost treatment efficiency. Built-in fire and static protection enhance safety. The automatic liquid supply system reduces labor input, fully complying with semiconductor production requirements.



Feature

- Stainless Steel
- Automatic Fire Extinguish System
- Customize for Manual and Fully Automatic
- Automatic Loading and Unloading platform
- ISO9001 Quality Assurance

Application

- Wafer Fabrication
- MEMS
- Photonic Chips
- Micronano Fabrication
- IC Substrate

Specifications:

Parameter	Descriptions
Wafer Size	4"~6"
Cleaning Capacity	25pieces2baskets or 4baskets/batch